



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 9324

Applicants : Takehiko FUJITA, et al.
U.S. Serial No. : 10/532,878
Filed : April 28, 2005
Examiner : Ram N. Kackar
Group Art Unit : 1763
For : THERMAL PROCESSING UNIT AND
THERMAL PROCESSING METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on July 12, 2007, please amend the above-identified application as set forth below and consider the following remarks.